INTERNATIONAL SEARCH REPORT

***--attoral Application No '/IB2004/050985 A. CLASSIFICATION OF SUBJECT MATTER
IPC 7 G01N21/17 G01N21/63 G01N29/24 According to International Patent Classification (IPC) or to both national classification and IPC B. FIELDS SEARCHED Minimum documentation searched (classification system followed by classification symbols) IPC 7 GOIN Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched Electronic data base consulted during the international search (name of data base and, where practical, search terms used) EPO-Internal, INSPEC C. DOCUMENTS CONSIDERED TO BE RELEVANT Category • Citation of document, with indication, where appropriate, of the relevant passages Relevant to claim No. US 6 174 739 B1 (STEFFAN PAUL J) 16 January 2001 (2001-01-16) figures 4,5 X 1-16 X LOGAN R ET AL: "MICROELECTRONIC FILM 1-16 THICKNESS DETERMINATION USING A LASER-BASED ULTRASONIC TECHNIQUE" MATERIALS RESEARCH SOCIETY SYMPOSIUM PROCEEDINGS, MATERIALS RESEARCH SOCIETY, PITTSBURG, PA, US, vol. 440, 1997, pages 347-352, XP001019773 ISSN: 0272-9172 page 350; figures 3,4 X US 6 256 100 B1 (ROGERS JOHN A ET AL) 1-16 3 July 2001 (2001-07-03) column 9; figures 7,8 -/--Further documents are listed in the continuation of box C. Patent family members are listed in annex.

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Date of mailing of the international search report
21/09/2004
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